

PATENT ASSIGNMENT

Electronic Version v1.1

Stylesheet Version v1.1

SUBMISSION TYPE:	CORRECTIVE ASSIGNMENT												
NATURE OF CONVEYANCE:	Corrective Assignment to correct the Assignee listing: INFINEON TECHNOLOGIES AG and IMS IONEN MIKROFABRIKATIONS SYSTEME GMBH. previously recorded on Reel 020710 Frame 0253. Assignor(s) hereby confirms the second assignee IMS IONEN MIKORFABRIKATIONS SYSTEME GMBH was inadvertently ommitted.												
CONVEYING PARTY DATA													
<table border="1"><thead><tr><th>Name</th><th>Execution Date</th></tr></thead><tbody><tr><td>Albrecht Ehrmann</td><td>08/09/2002</td></tr><tr><td>Ernst Haugendeger</td><td>08/09/2002</td></tr><tr><td>Frank - Michael Kamm</td><td>08/12/2002</td></tr><tr><td>Alexander Petraschenko</td><td>08/16/2002</td></tr><tr><td>Stefan Schunck</td><td>08/06/2002</td></tr></tbody></table>		Name	Execution Date	Albrecht Ehrmann	08/09/2002	Ernst Haugendeger	08/09/2002	Frank - Michael Kamm	08/12/2002	Alexander Petraschenko	08/16/2002	Stefan Schunck	08/06/2002
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RECEIVING PARTY DATA													
<table border="1"><tr><td>Name:</td><td>Infineon Technologies AG</td></tr><tr><td>Street Address:</td><td>St.-Martin Strasse 53</td></tr><tr><td>City:</td><td>Muenchen</td></tr><tr><td>State/Country:</td><td>GERMANY</td></tr><tr><td>Postal Code:</td><td>81669</td></tr></table>		Name:	Infineon Technologies AG	Street Address:	St.-Martin Strasse 53	City:	Muenchen	State/Country:	GERMANY	Postal Code:	81669		
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<table border="1"><tr><td>Name:</td><td>IMS IONEN Mikrofabrikations Systeme GmbH</td></tr><tr><td>Street Address:</td><td>Schreygasse 3</td></tr><tr><td>City:</td><td>Wien</td></tr><tr><td>State/Country:</td><td>AUSTRIA</td></tr><tr><td>Postal Code:</td><td>A-1020</td></tr></table>		Name:	IMS IONEN Mikrofabrikations Systeme GmbH	Street Address:	Schreygasse 3	City:	Wien	State/Country:	AUSTRIA	Postal Code:	A-1020		
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Property Type	Number												
Patent Number:	6773854												
CORRESPONDENCE DATA													
Fax Number: (954)925-1101													

OP \$40.00 6773854

Correspondence will be sent via US Mail when the fax attempt is unsuccessful.

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ATTORNEY DOCKET NUMBER:

W&B-INF-1268

NAME OF SUBMITTER:

Ralph E. Locher

Total Attachments: 7

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Docket No.: W&B-INF-1268

ASSIGNMENT

WHEREAS WE, ALBRECHT EHRMANN, ERNST HAUGENEDER, FRANK-MICHAEL KAMM, ALEXANDER PETRASCHENKO, and STEFAN SCHUNCK, residing respectively at KRAILING, Germany, WIEN, Austria, and UNTERHACHING, MÜNCHEN, and MÜNCHEN, Germany, have invented certain new and useful improvements in a

METHOD OF PRODUCING A PERFORATED MASK FOR PARTICLE RADIATION

for which an application for Letters Patent of the United States of America was executed on the date of execution of this assignment;

WHEREAS, INFINEON TECHNOLOGIES AG, a German corporation doing business at MÜNCHEN, Germany, and IMS IONEN MIKROFABRIKATIONS SYSTEME GMBH, a Austrian corporation doing business at WIEN, Austria, are desirous of acquiring the entire interest in said invention, and in any and all Letters Patent of the United States that may be obtained therefor;

NOW, THEREFORE, be it known that for and in consideration of my employment by the said corporations and other valuable consideration, the receipt and sufficiency whereof are hereby acknowledged, I have sold, assigned and transferred, and by these presents do sell, assign and transfer unto the said corporations, their legal representatives, successors and assigns, the full and exclusive right to the said invention as fully set forth and described in the above-mentioned application, and to said application and any and all divisions and continuations thereof, and any and all Letters Patent of the United States which may be granted therefor, and any and all reissues of said Letters Patent, the same to be held and enjoyed by the said corporations, their legal representatives, successors and assigns, to the full end of the term for which said Letters Patent may be granted or may be reissued or extended, as fully and entirely as the same would have been held by me had this assignment and sale not been made.

AND I hereby authorize the Commissioner of Patents to issue any and all Letters Patent of the United States on said invention or resulting from said Application and from any and all divisions and continuations thereof to the said corporations as the assignees of the entire right, title and interest in and to the same.

IN TESTIMONY WHEREOF, we have hereunto set our hands and seals.

In the presence of:

Albrecht Ehrmann (LS) Date: 9/8/2001
Witness ALBRECHT EHRMANN

Witness ERNST HAUGENEDER (LS) Date: _____

Docket No.: W&B-INF-1268

ASSIGNMENT

WHEREAS WE, ALBRECHT EHLMANN, ERNST HAUGENEDER, FRANK-MICHAEL KAMM, ALEXANDER PETRASCHENKO, and STEFAN SCHUNCK, residing respectively at KRAILING, Germany, WIEN, Austria, and UNTERHACHING, MÜNCHEN, and MÜNCHEN, Germany, have invented certain new and useful improvements in a

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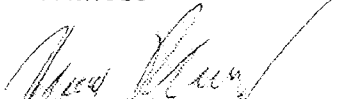
NOW, THEREFORE, be it known that for and in consideration of my employment by the said corporations and other valuable consideration, the receipt and sufficiency whereof are hereby acknowledged, I have sold, assigned and transferred, and by these presents do sell, assign and transfer unto the said corporations, their legal representatives, successors and assigns, the full and exclusive right to the said invention as fully set forth and described in the above-mentioned application, and to said application and any and all divisions and continuations thereof, and any and all Letters Patent of the United States which may be granted therefor, and any and all reissues of said Letters Patent, the same to be held and enjoyed by the said corporations, their legal representatives, successors and assigns, to the full end of the term for which said Letters Patent may be granted or may be reissued or extended, as fully and entirely as the same would have been held by me had this assignment and sale not been made.

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IN TESTIMONY WHEREOF, we have hereunto set our hands and seals.


In the presence of:

Witness


Witness

_____(LS)
ALBRECHT EHLMANN

Date: _____


_____(LS)
ERNST HAUGENEDER

Date: 9.8.02

PATENT

REEL: 020723 FRAME: 0004

[Signature]
Witness

F. H. Kamm (LS)
FRANK-MICHAEL KAMM

Date: 08/12/02

Witness

ALEXANDER PETRASCHENKO

Date: _____

Witness

STEFAN SCHUNCK

Date: _____

Witness

_____(LS)
FRANK-MICHAEL KAMM

Date: _____

A. Hinson

Witness (PPA Solution)

[Signature]
_____(LS)
ALEXANDER PETRASCHENKO

Date: 16.08.02

Witness

_____(LS)
STEFAN SCHUNCK

Date: _____

Witness

FRANK-MICHAEL KAMM (LS)

Date: _____

Witness

ALEXANDER PETRASCHENKO (LS)

Date: _____

Andi Schunck

Witness

Stef. Schunck

STEFAN SCHUNCK (LS)

Date: *August 6, 2002*